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JENTEK[®] Sensors, Inc. -

Nondestructive Evaluation of Cold Spray Repairs

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JENTEK issued and exclusively licensed patents include U.S. Patent #s 8,222,897, 8,050,883, 7,994,781, 7,876,094, 7,812,601, 7,696,748, 7,589,526, 7,533,575, 7,528,598, 7,526,964, 7,518,360, 7,467,057, 7,451,657, 7,451,639, 7,411,390, 7,385,392, 7,348,771, 7,289,913, 7,280,940, 7,230,421, 7,188,532, 7,183,764, 7,161,350, 7,106,055, 7,095,224, 7,049,811, 6,995,557, 6,992,482, 6,952,095, 6,798,198, 6,784,662, 6,781,387, 6,727,691, 6,657,429, 6,486,673, 6,433,542, 6,420,867, 6,380,747, 6,377,039, 6,351,120, 6,198,279, 6,188,218, 6,144,206, 5,966,011, 5,793,206, 5,629,621, 5,990,677 and RE39,206 (other US/foreign patents issued and pending).

Outline

- Technology Overview
- Success Story Examples
- Coating Thickness Measurement
- Disbond Detection and Imaging
- Cold Spray Coating Thickness and Quality
- Proposed Future Work

Core JENTEK Technologies

MWM®-Arrays

- Patented scanning and embeddable Eddy Current Sensor product
- Two decade lead over all technology in the market Solving problems that have been unsolved for decades Strong IP position

GridStation® Systems

Portable and Hand-Held versions

GridStation[®] Software using Hyperlattices[™]

 Performs multivariate inverse methods – i.e. fast, autonomous data analysis for decision support in NDT, CBM and SHM

Fuzzy-Hyperlattices

Remaining Useful Life Prediction (RUL) and rapid uncertainty estimation









MWM[®] & MWM-Array Eddy Current Sensors



JENTEK[®] Sensors, Inc.

Paradigm Shift

Design Sensors with rapid and accurate modeling as the primary focus



-Drive

(shown colored)

0.35" (9 mm)

7 Sensing elements

Example JENTEK MWM & MWM-Array Success Stories

Air Force/Navy Propeller Cold Work





Navy Disk Slot Inspection & Blade Dovetail Inspection



NASA Space Shuttle Leading Edge



Engine Component Inspection



Coating Thickness Measurements



Standard Practice for Characterization of Coatings Using Conformable Eddy-Current Sensors without Coating Reference Standards

This standard is issued under the fixed designation E 2338; the number immediately following the designation indicates the year of original adoption or, in the case of revision, the year of last revision. A number in parentheses indicates the year of last reapproval. A superscript epsilon (c) indicates an editorial change since the last revision or reapproval.

1. Scope

1.1 This practice covers the use of conformable eddycurrent sensors for nondestructive characterization of coatings without standardization on coated reference parts. It includes the following: (1) hitchesse measurement of a conductive coating on a conductive substrate, (2) detection and characterization of local regions of increased porosity of a conductive coatings on a conductive substrate or on a conductive coating This practice includes only nonmagnetic coatings on either magnetic ($\mu \neq \mu_0$) or nonmagnetic ($\mu = \mu_0$) substrates. This practice can also be used to measure the effective thickness of a process-affected zone (for example, shot penerd layer for a luminum alloys, alpha case for itanium alloys). For specific types of coated parts, the user may need a more specific procedure tailored to a specific application.

 Specific uses of conventional eddy-current sensors are covered by Practice D 7091 and the following test methods issued by ASTM: Test Methods B 244, E 376, E 1004, and G 12.

- D 7091 Practice for Nondestructive Measurement of Dry Film Thickness of Nonnagnetic Coatings Applied to Ferrous Metals and Nonnagnetic, Nonconductive Coatings Applied to Non-Ferrous Metals E 376 Practice for Measuring Coating Thickness by
 - Magnetic-Field or Eddy-Current (Electromagnetic) Examination Methods E 543 Specification for Agencies Performing Nondestruc-
 - tive Testing E 1004 Practice for Determining Electrical Conductivity
 - Using the Electromagnetic (Eddy-Current) Method E 1316 Terminology for Nondestructive Examinations
 - G 12 Test Method for Nondestructive Measurement of Film Thickness of Pipeline Coatings on Steel
 - 2.2 ASNT Documents:³
 - SNT-TC-1A Recommended Practice for Personnel Qualification and Certification In Nondestructive Testing
 - ANSI/ASNT-CP-189 Standard for Qualification and Certification of NDT Personnel
 - 2.3 AIA Standard:





Comparison of MWM with Metallographic MCrAIY Coating Thickness Measurements



Independent Evaluation by Siemens

Published, proceedings of ASME/IGTI Turbo Conference, June 2003, Atlanta, GA

H-60 Sump Repair Sites



H-60 Sump Repair Sites



Scanning Concept



MWM-Array FA24 Scans on Simulated Disbond Sample

MWM-Array FA24







ARL Sample



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Nominal Dimensions

- Al Cold-Spray Thickness: 70 mils (1.8 mm)
- Delamination Gap: 10 mils (0.25 mm)
- Mg Substrate Thickness: 275 mils (7 mm)





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Preliminary "Disbond" Imaging Results



MWM Coating Thickness Measurement & Q.A.



Single Sensing Element MWM Sensor FS33



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Measurement Lattice for Coating Characterization



Coating Thickness & Conductivity Measurement Results



Benet Labs Problem Definition

(Gun Barrel Coatings)

- Measure Four Unknowns
- Provide high resolution image of each unknown
- Automated & Real-Time



Low $f \sigma_{Ta}$ - Δ_{Ta} - h Lattice High $f \sigma_{Ta}$ - Δ_{Ta} - h Lattice $\mu_{\rm s}, \sigma_{\rm s}, \sigma_{\rm Cr}, \delta_{\rm Cr}$ constant $\mu_{\rm s}, \sigma_{\rm s}, \sigma_{\rm Cr}, \delta_{\rm Cr}$ constant -10 -10 σ_{Ta} (%IACS) 0.6 Increasing -20 -20 2.4 Increasing lift-off -30 lift-off 9.7 Phase (deg) -30 -40 -20 4.8 Phase (deg) -40 -50 -60 -70 Increasing -60 thickness -80 Increasing thickness -70 ⊑ 0.1 -90 ^Ŀ---0 0.5 0.05 0.2 0.3 0.4 0.6 0.1 0.15 0.25 0.3 0.2 0.35 Magnitude (µH) Magnitude (µH)

Zilberstein, V., Evans, L., Huguenin, C., Grundy, D., Shay, I., Goldfine, N., Mulligan, C., "Quality Assessment of Refractory Protective Coatings using Multi-Frequency Eddy Current MWM-Arrays," QNDE Conference, August 2005, AIP Conference Proceedings, Vol. 25B, pp 1067-1074, 2006.

Benet Labs Problem Definition

Schematics of 4-Unknown Constructs



Zilberstein, V., Evans, L., Huguenin, C., Grundy, D., Shay, I., Goldfine, N., Mulligan, C., "Quality Assessment of Refractory Protective Coatings using Multi-Frequency Eddy Current MWM-Arrays," QNDE Conference, August 2005, AIP Conference Proceedings, Vol. 25B, pp 1067-1074, 2006.

Benet Labs Program Results



Zilberstein, V., Evans, L., Huguenin, C., Grundy, D., Shay, I., Goldfine, N., Mulligan, C., "Quality Assessment of Refractory Protective Coatings using Multi-Frequency Eddy Current MWM-Arrays," QNDE Conference, August 2005, AIP Conference Proceedings, Vol. 25B, pp 1067-1074, 2006.

GridStation 8200 α System

Available for purchase as commercial product in early 2014

- 19 to 118 channel standard configuration
- 100× faster
- 10x Improved signal-to-noise
- 5Hz 20MHz operating frequency
- Windows[®] 8 operating system
- Intel Core i7, 3rd gen
- Multi-touch screen
- Weight: 8 lbs.
- Weight with probe electronics unit (PEU): 12 lbs







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